




Bib Data Sheet


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SERIAL NUMBER 09/484,051	FILING DATE 01/18/2000 RULE -	CLASS 257 165	GROUP ART UNIT 2811 3753	ATTORNEY DOCKET NO. SEC.0689	
APPLICANTS Chan-hoon Park, Seoul, KOREA, REPUBLIC OF ; ** CONTINUING DATA ***** n/a ** FOREIGN APPLICATIONS ***** OK - drc REPUBLIC OF KOREA 99-30350 07/26/1999 IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** ** 03/14/2000					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged  Examiner's Signature Initials		STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 11	TOTAL CLAIMS 23	INDEPENDENT CLAIMS 2
ADDRESS Jones Volentine LLP Suite 150 12200 Sunrise Valley Drive Reston, VA 20191					
TITLE Wafer heating apparatus having fluid heat transfer medium and method of heating a wafer using the same					
FILING FEE RECEIVED 744	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		